

# **pro flex**

**2019**

► ROLL-TO-ROLL COATING OF FLEXIBLE MATERIALS

**FOCUS 2019: TECHNOLOGY CROSS-OVER**



**PRESENTATIONS  
OF THE PREVIOUS  
CONFERENCES**

# PRESENTATIONS OF THE PREVIOUS CONFERENCES

2017

## Innovative application of ETFE films in architecture

PROF. DR. J. CREMERS

*Hochschule für Technik Stuttgart [Germany]*

## R2R processing of flexible glass substrates

S. C. LEWIS

*Corning Incorporated [USA]*

## Ultra-Clean and High Performance Substrates for Large Area Flexible Electronics

V. VON MORGEN

*DuPont Teijin Films Ltd., [UK]*

## Roll-to-roll Nanoimprint Lithography Patterning of Polymer surfaces and using it for patterned electrodes

DR. B. STADLOBER

*Joanneum Research Graz [Austria]*

## Direct laser ablation of nanoparticle-filled polymers for microstructured print and replication master surfaces

DR. U. HELMSTEDT

*Leibniz-Institut für Oberflächenmodifizierung [Germany]*

## All-in-one Roll-to-Roll solution producing flexible devices via additive printing and laser technology

C. RIEDEL

*3D-Micromac AG [Germany]*

## High-performance silver interconnects prepared on thin and ultrathin flexible substrates by inkjet-printing and laser treatment

DR. M. FRITSCH

*Fraunhofer IKTS [Germany]*

## R2R production of anisotropic conductive polymer films

DR. H. HEMMEN

*Condalign AS [Norway]*

## Industrial scale production of low cost, transparent, low resistance (1 Ohm/sq) flexible electrode

A. DOLBUNOV

*FunNano USA Inc. [USA]*

## Atmospheric Pressure SDBD plasma treatment for printed electronics applications

PROF. DR. C.I.M.A. SPEE

*Maan Research & Development B.V. [Netherlands]*

## Resource and Energy Efficient Coating of Flexible Substrates by Roll-to-Roll Atomic Layer Deposition at Atmospheric Pressure

D. BAUER

*Fraunhofer IIV [Germany]*

## Upscaling Roll-To-Roll Atomic Layer Deposition to Production

DR. D. BORSA

*Meyer Burger (Netherlands) B.V. [Netherlands]*

## Roll-to-roll deposition of high performance gas diffusion barriers on polymers using a new atmospheric plasma technology platform

S. STAROSTIN

*FUJIFILM Manufacturing Europe B.V. [Netherlands]*

# PRESENTATIONS OF THE PREVIOUS CONFERENCES

2017

## Electronic or smart fabrics - considerations for scale-up

DR. C. A. BISHOP [UK]

## Compact Roll-2-Roll multipurpose coating system for DC, quasi-DC and AC sputtering

T. NIEDERHAUSEN

VON ARDENNE GmbH [Germany]

## Application of Bipolar Pulsed Magnetron Sputtering and Bipolar High Power Impulse Magnetron Sputtering for functional coating deposition on flexible substrates

W. GAJEWSKI

TRUMPF Huettinger [Germany]

## The exceptional performance of the Cascade Coater

M. GRAF ZU EULENBURG

InovisCoat GmbH [Germany]

## Intermittent Slot die coating

DR. K. CRONE

Coatema Coating Machinery GmbH [Germany]

## Improving the Performance of Ceramic Barrier Layers used in Packaging Materials

N. MORRISON

Applied Materials, Inc. [USA]

## Flexible Packaging: Ressource Effeciency and Recycleability

PROF. DR. A. GREFENSTEIN

Constantia Hueck Folien GmbH & Co. KG [Germany]

## Advanced R2R Metallizing For Flexible Packaging & Security

PROF. N. AHMED

Idvac Ltd. [UK]

## Flexible protected metallized polymeric reflector for use in „Heliotube“- solar – thermal energy conversion plants

DR. R. THIELSCH

Southwall Europe GmbH, a subsidiary of Eastman Chemical Company [Germany]

## Encapsulation technology for OLED or OPV modules

DR. T. IZUMI

Lintec Corporation [Japan]

## High-Volume Solution Processed OLEDs Using a Roll-to-Roll Pilot Coating Line

H. GORTER

Holst Centre [Netherlands]

## Thin glass OLEDs and the challenges in roll-to-roll production

DR. W. DÖTTER

OLED Works [USA]

## Challenges in the Design and Manufacture of OLED Lighting

DR. N. BARDSLEY

Bardsley Consulting [UK]

# PRESENTATIONS OF THE PREVIOUS CONFERENCES

2013

## New technologies for vacuum roll-to-roll coating PECVD for high barrier coatings – Sputter deposition on flexible glass

H. TAMAGAKI, T. OKIMOTO, Y. KUROKAWA, T. SEGAWA, Y. IKARI, N. OHBA

Kobe Steel Ltd. [Japan]

## Ultra-thin flexible glass substrates for electronics applications

J.-M. JOUANNO

Corning Inc. [USA]

## A study of adhesive improvement of a Cr-Ni alloy layer on a polyimide surface by low pressure gas plasma modification

K. MIYAUCHI, H. YAMABE, M. YUASA

Sumitomo Metal Mining Co., Ltd. [Japan]

## Successful substrate cleaning in a high vacuum environment

S. HAMILTON

Teknek, Ltd. [UK]

## Managing flexible webs for vacuum roll-to-roll deposition for electronic or ultra-barrier applications

C. A. BISHOP

C. A. Bishop Consulting, Ltd. [UK]

## Flexible solar cells

U. BEWERSDORFF-SARLETTE

Heliatek GmbH [Germany]

## Printing versus coating technologies – In which direction the future production technologies for printed electronic is going?

A. GLAWE, F. SCHÄFER

KROENERT GmbH & Co. KG [Germany]

## Freeform and flexible electronics manufacturing using roll-to-roll printing and hybrid integration techniques

J. HAST, K. RÖNKÄ

VTT Technical Research Centre of Finland [Finland]

## Roll-to-roll processing of flexible OLEDs

C. LEHMANN, S. MOGCK, T. WANSKI, C. MAY

Fraunhofer COMEDD [Germany]

## Direct laser interference patterning, a new tool for large area surface functionalization of flexible materials

A.-F. LASAGNI, S. ECKHARDT, J. BERGER, D. BENKE

Fraunhofer IWS [Germany]

## Activities of Saint Gobain in window film

C. LEYDER

Saint Gobain Performance Plastic [France]

## Roll-to-roll processes and equipment for displays: State of the art and outlook

R. KUKLA, N. MORRISON, T. DEPPISCH

Applied Materials GmbH & Co. KG [Germany]

## Piloting roll-to-roll ALD – Status and results with 500 mm wide web system

M. SÖDERLUND, P. SOININEN

Beneq Oy [Finland]

## Spatial atmospheric atomic layer deposition for next-generation flexible devices

F. ROOZEBOOM, P. POODT, A. ILLIBERI

Holst Centre TNO [The Netherlands]

# PRESENTATIONS OF THE PREVIOUS CONFERENCES

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## ALD and MLD passivation layers for flexible OLED and OPV

C. HOSSBACH, H. KLUMBIES, F. NEHM, C. RICHTER, A. SINGH, C. KEIBLER, M. GEIDEL, L. MÜLLER-MESKAMP, U. SCHRÖDER, M. ALBERT, J. W. BARTHA

*Technische Universität Dresden, Institute for Semiconductor and Microsystems Technology (IHM) [Germany]*

## PPD – An innovative technology for deposition on flexible substrates

C. TALIANI, A. NERI, D. YARMOLICH

*Organic Spintronics Srl. [Italy]*

## Flash lamp annealing: High temperature processing of layers on flexible substrates

T. GEBEL, H. LIEPACK, M. NEUBERT, W. SKORUPA, R. ENDLER

*DTF Technology GmbH [Germany]*

## Rotatable magnetron sputtering in roll-to-roll web coating of optical layer stacks

H. PRÖHL, M. DIMER, M. HENTSCHEL, F. OTTO, J. STRÜMPFEL

*VON ARDENNE Anlagentechnik GmbH [Germany]*

## The gas barrier and adhesion properties of organic thin layer deposited by physical vapor deposition

T. EBATA

*TOYOB0 Co. Ltd. [Japan]*

## The effects of intrinsic and extrinsic defects on moisture-barrier coatings on polymer substrates

A. SMITH, D. BIRD, D. ROBBINS, S. EDGE, A. COOK

*The Centre for Process Innovation Ltd., CPI [UK]*

## High performance gas barrier encapsulating materials for flexible organic devices

Y. HAGIHARA, K. NISHIJIMA, S. NAGANAWA, K. NAGAMOTO, T. KONDO

*LINTEC Corporation R&D Div. Research Center [Japan]*

## RF plasma polymer coating on polymeric substrates: Study of barrier properties

S. LIGOT, C. NOUVELLON, F. AJOUAOUI, F. RENAUD, R. SNYDERS

*Université de Mons [Belgium]*

## Photochemical approach to thin barrier films for the encapsulation of flexible laminar electronic devices

L. PRAGER, U. HELMSTEDT, H. HERRNBERGER, M. MÜNCH, O. KAHLE, F. KITA, A. PENDER, M. STASIAK

*Leibniz-Institut für Oberflächenmodifizierung IOM [Germany]*

## Ultra-low water vapor permeation measurement using Tunable Laser Absorption Spectroscopy (TDLAS)

W. GRÄHLERT, H. BEESE, J. GRÜBLER, J. KOCH, K. PIETSCH

*Fraunhofer IWS [Germany]*

# PRESENTATIONS OF THE PREVIOUS CONFERENCES



2010

## Advanced Plasma Technology for Large Area PECVD Processes on Flexible Substrates

J. LANDROCK, M. ZEUNER, M. NESTLER, S. WINKLER, D. ROST

*Roth & Rau MicroSystems GmbH*

## Dynamic VHF-PECVD Deposition Concept Tool with Linear Plasma Sources for Flexible Substrate Coating

C. STROBEL, B. LESZCZYNSKA, M. ALBERT, T. ZIMMERMANN, J. KUSKE, J. W. BARTHA

*Technische Universität Dresden*

## PVD / PECVD Web Processing Solutions

S. KREHER, L. KÖHLER

*FHR Anlagenbau GmbH*

## Recent Developments in Fast and Fine Temperature Measurement

U. KRAUSE, M. RITZHEIMER

*Advanced Energy Industries GmbH*

## Roll-to-Roll ALD for Coating of Polymer Webs

M. SÖDERLUND, P. SOININEN, S. SNECK

*Beneq Oy*

## Advanced Oxygen Plasma Polymer Substrate Pre-Treatment and Coating for Flexible Electronics Applications

M. AUDRONIS, V. BELLIDO-GONZALEZ

*Gencoa Ltd.*

## Effects of Oxygen Plasma Surface Treatment on BOPP Film

S. F. DRIBINSKIY, C. STRULLER, H.-C. LANGOWSKI

*Fraunhofer-Institut für Verfahrenstechnik und Verpackung IVV*

## Moisture Barrier on Plastic Substrates by Atomic Layer Deposition (ALD) and Sputtering

A. SMITH

*CPI-PETEC*

## Large Scale Flexible Electrochromic Devices: Towards Roll-to-Roll Processing

E. AVENDANO, S. VON KRÆMER, T. ALMESJÖ, C. G. GRANQVIST

*ChromoGenics AB*

## Production Proven Vacuum Web Coating System for Robust and Environmentally-Friendly Transparent Barriers

R. LUDWIG, H.-G. LOTZ, G. HOFFMANN

*Applied Materials GmbH & Co. KG*

## Nanoparticulate Barrier Films and Encapsulation Method for Solar and Display Applications

S. RAMADAS, S. ZIN MA, S. SHANMUGAVEL

*TERA-BARRIER FILMS PTE. LTD.*

## ITO for Flexible Electronics Applications

S. LOUCH

*CPI-PETEC*

## The Development of Transparent Conductive Films of Organic-Inorganic Lamination Type

N. TATAMI

*TOYOB0 Co., Ltd.*

## Demands on Barrier for Organic PV on Flexible Substrates

U. BEWERSDORFF-SARLETTE

*heliatek GmbH*

# PRESENTATIONS OF THE PREVIOUS CONFERENCES

2010

## Characterization of Ultra-Barrier Films

C. BOEFFEL, A. HOLLÄNDER

*Fraunhofer-Institut für Angewandte Polymerforschung IAP*

## Photovoltaic and OLED Applications: Optical in-situ and in-line Metrology for Advanced Roll-to-Roll Thin-Film Processes

T. RIEDLE, S. UREDAT

*LayTec GmbH*

## Magneto-Optical Studies of Magnetic Clusters and Thin Films on PET Substrates

K. SCHMIDEGG, V. RINNERBAUER, M. HOHAGE, L. D. SUN, P. ZEPPENFELD

*Hueck Folien GmbH*

## Imaging Technologies for Reliability Assessment in Flexible Photovoltaics

T. SWONKE, M. WAGNER, C.-J. BRABEC, U. HOYER, J. BACHMANN, C. BUERHOP-LUTZ

*Bayerisches Zentrum für Angewandte Energieforschung (ZAE Bayern)*

## Insulating Layers on Flexible Metallic Substrates

F. HÄNDL, C. METZNER, H. MORGNER

*Fraunhofer-Institut für Elektronenstrahl- und Plasmatechnik FEP*

## Permeation Testing for Organic Electronics: Review of Needs and Technological Options

G. NISATO, T. BEIERLEIN, G. BASSET

*CSEM Centre Suisse d'Electronique et de Microtechnique SA*

## System Integration Technologies on Polymer Substrates

K. BOCK

*Fraunhofer-Einrichtung für Modulare Festkörper-Technologien EMFT*

## Laser Scribing of Organic Solar Cells

R. NEUBERT, J. HÄNEL, C. SCHOLZ, M. CLAIR

*3D-Micromac AG*

## R2R Production Solutions for Touch Panels, Flex PV and other Flex Electronic Applications

R. KUKLA, P. SAUER, H.-G. LOTZ

*Applied Materials GmbH & Co. KG*

## OLED for Lighting – R2R Fabrication and Inspection

S. MOGCK, C. MAY

*Fraunhofer-Institut für Photonische Mikrosysteme IPMS*

## Low E Coatings on Flexible Substrate for IGU Applications

R. KLEINHEMPPEL, G. SPITZER, A. WAHL, R. WIPFLER, J. KOZAK, L. BOMAN, R. THIELSCH

*Southwall Europe GmbH*

## Recent Developments in Silicon Based Solar Cells Deposited on Plastic Film

Y. ZIEGLER, D. FISCHER, L. SANSONNENS, P. COUTY

*VHF-Technologies*

## Silicon-Light: a New EU Project on Roll-to-Roll Fabrication of Thin Film Silicon Solar Cells on Foil

W. J. SOPPE

*Energy research Centre of the Netherlands (ECN)*

## Rigid and Flexible Solar Modules from a CIGS Roll-to-Roll Pilot Line

A. BRAUN

*Solarion AG*

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2010

## Manufacturing and Applications of Cu(In,Ga)Se<sub>2</sub> Solar Cells on Flexible Substrates

D. BRÉMAUD  
FLISOM Ltd.

## Magnetron Based PECVD: an Innovative High-Speed Process

M. FAHLAND, J. FAHLTEICH, W. SCHÖNBERGER, A. SCHÖNBERGER, S. BUNK, N. SCHILLER  
*Fraunhofer-Institut für Elektronenstrahl- und Plasmatechnik FEP*

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2007

## Control of a sheet resistance and light transmission in TCO production

V. KOZLOV, E. MACHEVSKY

*Sidrabe Inc., Latvia*

## About the manufacturing of EMI-NIR locking filter based on Ag and ITO multi-layer coatings on flexible substrate for plasma display panel application

A. WAHL, R. THIELSCH, T. BOEHME

*Southwall Europe GmbH, Germany*

## Study of influence of under layer on Indium Tin Oxide crystallization

H. MURAKAMI, T. OYA, S. MATSUDA, K. ITO

*Toyobo Co., Japan*

## 2D Web coating simulator software

I. TARTAKOVSKY

*4S Scientific Ltd, Israel*

## Recent developments in plasma generation for web coating applications

T. LINZ, U. KRAUSE, M. LUTZ

*Advanced Energy Industries GmbH, Germany*

## Roll-to-roll surface modification of fluoropolymers

M. DANZIGER, W. VOITUS

*IST - Ionen Strahl Technologie - GmbH, Germany*

## Plasma surface treatment

B. N. GUPTA

*Polyplex Corporation Ltd., Noida, India*

## Precise power for flexible substrate coating

D. OCHS

*HUETTINGER Elektronik GmbH + Co KG, Germany*

## Wet coating - opportunity for ultrathin layers

W. SCHUBERT

*Universal-Beschichtung GmbH, Germany*

## Flexible printing of transparent conducting oxides for display applications

J. PUETZ

*Leibniz-Institut für Neue Materialien, Germany*

## Roll to roll sputtering for flexible electronic applications

R. KUKLA

*Applied Materials GmbH & Co. KG, Germany*

## Laser machining of thin films on top of flexible substrate carriers

J. HÄNEL, B. KEIPER

*3D-Micromac AG, Germany*

## Permeation Barrier Properties of Oxide Layers on Polymer Film Deposited by Pulsed Magnetron Sputtering

J. FAHLTEICH, M. FAHLAND, N. SCHILLER, W. SCHÖNBERGER

*Fraunhofer Institute for Electron Beam and Plasma Technology, Germany*

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2007

## Specialty films for organic solar cells

J. HAUCH

*Konarka Technologies GmbH, Germany*

## Flexible Silicon based solar cells: challenges and chances

R. SCHLATMAN

*Helianthos b.v., The Netherlands*

## CIGS thin film solar cells on polymer substrates – the next generation of photovoltaics

K. OTTE, A. BRAUN

*Solarion AG, Germany*

## The European Project FLEXCELLENCE: roll to roll technology for the production of high efficiency low cost thin film solar cells

V. TERRAZZONI-DAUDRIX, C. BALLIF, F.-J. HAUG

*Institute of Microtechnology, University of Neuchâtel, Switzerland*

D. FISCHER

*VHF Technologies S.A., Yverdon-les-Bains, Switzerland*

W. SOPPE, J. LOFFLER

*ECN Solar Energy, The Netherlands*

J. ANDREU

*University of Barcelona (UBA), Spain*

M. FAHLAND

*Fraunhofer Institute for Electron Beam and Plasma Technology, Germany*

H. SCHLEMM

*Roth&Rau Oberflächentechnik AG (R&R), Germany*

M. TOPIC

*University of Ljubljana, Slovenia*

S. GEIGER

*Carl BAASEL Lasertechnik, Rofin (ROF), GmbH & Co. KG, Germany*

## Production and coating techniques for polymer solar cells

K. NORRMAN, M. JØRGENSEN, T. D. NIELSEN, F. C. KREBS

*Riso National Laboratory, Denmark*

## High efficiency flexible solar cells: challenges and prospects of manufacturing and applications

D. BREMAUD, A. N. TIWARI

*Thin Film Physics Group, ETH Zurich, Switzerland*

## Permeation measurements at 0.001 g/m<sup>2</sup>/day and below for applications in flexible electronics

H. NORENBERG

*Technolox Ltd., United Kingdom*

## In-line monitoring of ultrathin metallic films on PET substrates with sub-nm resolution

K. SCHMIDEGG, M. BERGSMANN

*HUECK FOLIEN GmbH, Austria*

L. SUN, M. HOHAGE, P. ZEPPENFELD

*Institut für Experimentalphysik, Johannes Kepler Universität, Austria*

# PRESENTATIONS OF THE PREVIOUS CONFERENCES

2007



## **Roll-to-roll fabrication of OLED on metal foils for lighting applications**

C. MAY

*Fraunhofer-Institut für Photonische Mikrosysteme, Germany*

T. CANZLER

*Novaled AG, Germany*

C. DEUS

*Von Ardenne Anlagentechnik GmbH, Germany*

K. LEO

*Technische Universität Dresden, Institut für angewandte Photophysik, Germany*

N. SCHILLER

*Fraunhofer Institute for Electron Beam and Plasma Technology, Germany*

H. SCHWAB

*Philips Licht, UB der Philips GmbH, BU-SSL-OLED, Germany*

S. UREDAT

*Laytec Gesellschaft für in-situ und Nanosensorik mbH, Germany*

J. DRECHSEL

*CreaPhys GmbH, Germany*

## **Advanced process control for surface treatment in roll-to-roll and other processes**

M. SCHULZE

*AIS Automation Dresden GmbH, Germany*

## **XRF-Inline measuring unit - an important tool to control coating processes**

J. PILTZ

*amtec Analysenmesstechnik GmbH, Germany*

## **On-line plasma monitoring for product optimization**

D. MONAGHAN, V. BELLIDO-GONZALEZ, B. DANIEL, S. COUNSELL

*Genco Ltd., United Kingdom*

## **In-situ layer thickness measurement by spectral reflectance measurement**

S. UREDAT, J.-T. ZETTLER

*LayTec GmbH, Germany*

M. ERITT, C. MAY

*Fraunhofer IPMS, Germany*

## **Development of new linear ion beam source for vacuum web coating**

D.-H. PARK, W.-K. CHOI

*Korea Institute of Science and Technology, Korea*

## **High adhesion coatings on polymer films for flexible circuit boards**

S. GÜNTHER, B. MEYER, W. SCHÖNBERGER, N. SCHILLER

*Fraunhofer Institute for Electron Beam and Plasma Technology, Germany*

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2004

## Design Features of Sputter Roll Coaters and Application of Optical Multi Layers on Flexible Substrates

J. STRÜMPFEL

VON ARDENNE Anlagentechnik GmbH

## SMARTWEB, A new Vacuum Web Coater with Multiprocess Capabilities

R. KUKLA

Applied Films GmbH & Co. KG

## Copper-Indium-Gallium-DiSelenide based Thin Film Solar Cells on Polyimide

G. LIPPOLD, A. BRAUN

Solarion GmbH

## ColorSwitch - A New Security Feature Made by Ultra-Thin Coating Technique

M. BERGSMANN

Hueck Folien GmbH & Co. KG

## Influences on resistance heated boats in web coating

K. SCHAFSTECK, U. BRAUN

Leybold Optics GmbH

## Sputter-coated plastic web for FPD-applications

R. THIELSCH

Southwall Europe GmbH

## Optical in-situ process monitoring using spectroscopic ellipsometry and Raman scattering

C. BUNDESMANN, M. SCHUBERT, N. ASHKENOV

Universität Leipzig, Institut für Experimentelle Physik II

G. LIPPOLD

Solarion GmbH

## Electron Beam Web Coating of Silicon Oxide On Production Scale

W. LOHWASSER

Alcan Packaging Services Ltd.

## Barrier films for vacuum insulation panels

D. KACZMAREK, S. JACOBSEN

Wipak Walsrode GmbH & Co.KG

## Ion track technology for the production of polymeric foils with nanostructures and for vacuum surface treatment methods

M. DANZIGER

IST - Ionen Strahl Technologie - GmbH

## Linear Ion Source for In-Line Treatment of Polymers and Glass

T. LINZ, D. SHAW, J. MUELLER, M. FRATI

Advanced Energy Industries GmbH

R. RANK, M. FAHLAND

Fraunhofer-Institut für Elektronenstrahl- und Plasmatechnik FEP

## Production and Applications of flexible printed circuits

L. ULLMANN

Fractal AG

## Microwave assisted sputtering for polymers

S. MOH

University of Paisley, Thin Film Center

2004

## Vacuum Equipment for TCO and AR Coatings Deposition by Reactive Magnetron Sputtering

V. KOZLOV, E.YADIN, E.MACHEVSKIS

*Sidrabe Inc.*

## SiOx Hard Coat Films Deposited at High Rates by a Novel PECVD Roll to Roll Process

J. MADOCKS

*Applied Process Technologies Inc.*

## Reactive Gas Control of Non Stable Plasmas

D. MONAGHAN, V. BELLIDO-GONZÁLES, B. DANIEL, J. COUNSELL

*GENCOA Ltd.*

## Permeation Studies of Gas Barrier Films

B. M. HENRY, J. TOPPING, H. E. ASSENDER, C. R. M. GROVENOR

*University of Oxford, Department of Materials*

## EBPVD Roll Coater and Related Technology Issues for Coating on Flexible Materials

C. STEUER

*VON ARDENNE Anlagentechnik GmbH*

## Low damage processing of thin films on flexible substrates by ultra-short pulse lasers

K. ZIMMER, D. RUTHE

*IOM Leibniz-Institut für Oberflächenmodifizierung e. V.*

T. HÖCHE, J. HÄNEL

*3DMM 3D-Micromac AG*

A. BRAUN

*Solarion GmbH*

## Roll-to-roll laser patterning of vacuum coated flexible substrates

D. MEIER

*LPKF Laser & Electronics AG*

## In-line Monitoring of coating processes with fiber optical spectrometers - possibilities and limitations

C. P. RENSCHEN

*OPTOcon GmbH*

## Forgery-proof optical codings made by vacuum coating

R. DOMNICK

*identif GmbH*

## UV Curing: Plain and structured coatings as sub- and superstrate for vacuum web coatings

J. V. SONNTAG

*IOM*

## Thickness and element contents of thin films on foils - measured online by X-ray

J. PILTZ

*Amtec*

## Coating of polymer films with low resistance transparent electrodes

M. FAHLAND, C. CHARTON

*Fraunhofer-Institut für Elektronenstrahl- und Plasmatechnik FEP*